

FORM PTO-1449  
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
RD-28,694SERIAL NO.  
10/064,888

INFORMATION DISCLOSURE STATEMENT BY APPLICANT  
LIST OF ITEMS

Applicant  
Marc (NMN) Schaepekens et al.Filing Date  
8/27/02Group  
1763

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>ME</i>	A1	6,110,544	8/29/00	Yang et al.		
<i>ME</i>	A2	6,261,694	7/17/01	Iacovangelo		
<i>ME</i>	A3	6,376,064	4/23/02	Gasworth et al.		
<i>ME</i>	A4	6,397,776	6/4/02	Yang et al.		
<i>ME</i>	A5	6,420,032	7/16/02	Iacovangelo		
<i>ME</i>	A6	6,426,125	7/30/02	Yang et al.		

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	B1					
	B2					

## OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

<del>C1</del>	<del>Application RD-25,955, Serial No. 09/271,656, filed March 17, 1999</del>
<del>C2</del>	<del>Application RD-28,484, Serial No. 09/683,148, filed November 27, 2001</del>
C3	
C4	
C5	
C6	
C7	
C8	

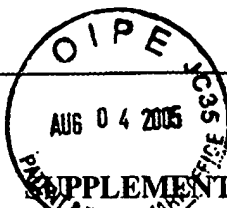
EXAMINER

*Mameen R. Francis*

DATE CONSIDERED

03/29/2006

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

FORM PTO-1449  
(REV. 7-80)US. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
RD-28,694-1SERIAL NO.  
10/064,888

**SUPPLEMENTAL**  
**INFORMATION DISCLOSURE STATEMENT BY APPLICANT**  
**LIST OF ITEMS**

Applicant  
Marc Schaepekens et al.Filing Date  
8/27/02Group  
1753 1763**U.S. PATENT DOCUMENTS & U.S. PATENT APPLICATION PUBLICATIONS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>ms</i>	A1	6,093,903	7/25/00	Schneider		
<i>ms</i>	A2	2003/0099784	5/29/03	Schaepekens		
<i>ms</i>	A3	2003/0121887	7/3/03	Garvey et al.		
	A4	2004/0040833	3/4/04	Schaepekens et al.		
	A5					
	A6					
	A7					

Instant  
application**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
<i>ms</i>	B1	EP 0 249 238	12/16/87	European		X
	B2					
	B3					
	B4					
	B5					
	B6					

**OTHER INFORMATION** (Including Author, Title, Date, Pertinent Pages, etc.)

<i>ms</i>	C1	M. Schaepekens et al., "High-Rate Deposition of Abrasion Resistant Coatings Using a Dual-Source Expanding Thermal Plasma Reactor", American Vacuum Society, Journal of Vacuum Science and Technology A, Volume 21, No. 4, pp. 1266-1271, 2003.
<i>ms</i>	C2	International Search Report dated June 24, 2005.
	C3	
	C4	
	C5	

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*Maureen J. Chancé*

DATE CONSIDERED

03/29/2006

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